

BT · ET

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. 9 , 11

BT, NT, ET, 가
KAIST, 6 . 3

9

2 , 가가

KAIST

(2002)

NT				(1999)
	3 / ,			lithography stepper (1994)
BT				가 (AOTF) (2001)
BT				(1999)
BT				(1997)
ET				(1999)
ET	2 ,			(2001)
NT	ITO ITO Sputtering Target			ITO (2000)
ET				(1999)

9 가 , . .